| | PATENT |
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| IN THE UT | ED STATES PATENT AND TRADEMAR. FFICE |
| າງ 2003 ຢູ່ In resthe application of: |) AL |
| CHER et al. | Group Art Unit: 2821 |
| TRAUS | Examiner: LEE, Wilson |
| Application No: 10/077,072 |) Atty. Docket No: P0877 9-5 |
| Filed: February 14, 2002 |) Date: August 19, 2003 |
| For: A PLASMA PROCESSI AND METHOD FOR CONFI | |
| PLASMA UNDER VERY HIG | GH GAS FLOW) |
| AND RF POWER DENSITY | CONDITIONS) |
| | CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 19, 2003 Signed: Sharon Tillery |
| REQUEST FOR | CONTINUED EXAMINATION (RCE) TRANSMITTAL |
| Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: | CONTINUED EXAMINATION (RCE) TRANSMITTAL C 2800 MAIL ROOM |
| 1. Submission required under 37 | 7 C F R & 1 114 |
| a. | the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on the arguments in the Appeal Brief or Reply Brief previously filed on ent/Reply (s)/Declaration(s) on Disclosure Statement (IDS) eliminary Amendment tion on the above-identified application is requested under 37 C.F.R. § 1.103(c) |
| Date: August 19, 2003 | May 5 |
| | Michael S. Brandt, Esq. Reg. No. 39,119 |

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